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In re Application of	:	
Selvamanickam	:	
Serial Number: 10/602,467.	:	
Filed: June 23, 2003	:	PETITION UNDER
For: APPARATUS FOR HIGH-THROUGHPUT ION	:	M.P.E.P. 708.02 IX
BEAM-ASSISTED DEPOSITION (IBAD)	:	

This is in response to the petition filed February 12, 2004, requesting that the above-identified application be granted Special Status under Section 708.02 IX of the MPEP and 37 CFR 1.102 (b) (**no fee required**).

The request for Special Status considered under Section 708.02 IX of the MPEP is granted because criteria under 37 CFR 1.102(b) has been met.

Accordingly the petition is **GRANTED**.



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